

INDIAN INSTITUTE OF TECHNOLOGY BOMBAY MATERIALS MANAGEMENT DIVISION Powai, Mumbai 400076.

PR No. 1000042357

Rfx. No.6100001955

<u>Technical specifications for the Add on components "ALD tool perovskite PV device stack fabrication tool" for existing glove box.</u>

Sr. No	Item Description		Detailed Technical Specification	Technical Compliance (Yes / No)	Additional Information (if any)
1.	Add components	on	• ALD tool for Perovskite PV device stack fabrication tool: Temperature-controlled all aluminum chamber, up to 300 degree Celsius, with up to M-10 square sample holder - Heated chamber isolation valve for high exposure, high conformality processes -Dedicated process kit with optimized precursor flow path and all metal sealing upstream of sample -Precursor input: 1. Process Gas 2. High Vapor pressure liquid oxidant (H2O or H2O2) 3. Solid or liquid metal sources -All sources include heated, integrated dose columes for precise and quantifiable precursor delivery 4. Thermal ALD valves 5. High temperature dose volume fill valves -Metal sealed, 200 sccm MFC for N2 or Ar purge flow control -Fully automated temperature control system for bottles, dose volumes, precursor delivery manifold and chamber -Chamber heater control based on dual temperature probes for accuracy and as probe failure failsafe -16-bit7" color touchscreen control and PLC operation - Proprietary software embedded in PLC with integrated process recipes - 12-month warranty (labor and non-consumable parts) - 36-month complete process development support and lifetime process development assistance		

* Conformal heating jacket with secondary elbow	Τ
heater:	
- For operation to 150C	
* Large chamber for ALD:	
-Design for large chamber, platen, door and supports for	
M-10 square substrates (182 x 182 mm).	
-Manufacture new parts from 304 SS and 6061 aluminums	
Internal rails for transfer interface	